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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

912

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10038990	01/04/2002	148	7.1	2812	
**APPLICANTS: Joo Seung-Ki; Lee Seok-Woon;					
**CONTINUING DATA VERIFIED: No n					
** FOREIGN APPLICATIONS VERIFIED: REPUBLIC OF KOREA 2001-385 01/04/2001 Yes n					
PG-FUB <input type="checkbox"/> DO NOT PUBLISH		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 condition's met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials				ATTORNEY DOCKET NO 069457.0106	
TITLE : Method and apparatus for fabricating a semiconductor device					
U.S. DEPT. OF COMM./PAT. & TM. PTO-436L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner PREPARED FOR ISSUE Application Examiner	
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